

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket Number (Optional)

010452

Application Number

09/787,661

Applicant(s)

Tillack et al.

Filing Date

21 March 2001

Group Art Unit

2812

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
E	A	4,221,044	9/1980	Godejahn et al.	29	571	
E	B	4,396,933	8/1983	Magdo et al.	357	50	

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
E	a	0 241 316	10/1987	E.P.O.	H01L	21/205		✓
E	b	01183114	7/1989	Japan	H01L	21/205	✓	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

E	aa	Zheng Qi-jing et al: Nucleation and Early Stage Growth of Polycrystalline Silicon Deposition; J. Nanjing Inst. Technol. (China), Journal of Nanjing Institute of Technology, 1982, China
E	bb	Ryum, B.R et al.: MBE-grown SiGe Base HBT with Polysilicon-Emitter and TiSi ₂ Base Ohmic Layer; Solid-State Electronics Vol. 39, No. 11, pp. 1643-1648

EXAMINER

Christopher Lattin

DATE CONSIDERED

11/30/01

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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							YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	a	Patent Abstracts of Japan: Publication No.: 63006874; Publication Date: 1 December 1988
	b	Patent Abstracts of Japan: Publication No.: 62036865; Publication Date 2 February 1987

EXAMINER

Christopher L. Tillack

DATE CONSIDERED

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